



**PATENT**  
Atty Docket No. KLAC0012

I CERTIFY THAT ON FEBRUARY 19, 2002, WHICH IS THE DATE I AM SIGNING THIS CERTIFICATE, THIS CORRESPONDENCE AND IDENTIFIED ENCLOSURES ARE BEING DEPOSITED IN THE UNITED STATES POSTAL SERVICE, POSTAGE PAID FIRST CLASS, IN AN ENVELOPE ADDRESSED TO: COMMISSIONER OF PATENTS AND TRADEMARKS, WASHINGTON, D.C. 20231.

STEVEN W. SMYRSKI

131C  
Smyrski  
3/9/03

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

CHRISTOPHER FAIRLEY, ET AL.

Title: CONFOCAL WAFER INSPECTION  
METHOD AND APPARATUS

Serial No.: 09/533,203

Filed: MARCH 23, 2000

Group Art Unit: 2878

Examiner: Eric J. Spears

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**AMENDMENT ACCOMPANYING REQUEST FOR CONTINUED  
EXAMINATION (RCE)**

Hon. Commissioner of Patents and Trademarks  
Washington, D.C. 20231

Sir:

In response to the Office Action dated November 19, 2002, please consider the following remarks in connection with the above-identified patent application.